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<b>APPLICANTS</b> Srinivas Doddi, Fremont, CA; Emmanuel Drege, San Jose, CA; Nickhil Jakatdar, Los Altos, CA; Junwei Bao, Santa Clara, CA;				
<b>** CONTINUING DATA *****</b> NONE AB				
<b>** FOREIGN APPLICATIONS *****</b> NONE AB				
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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <input type="checkbox"/> Allowance <input checked="" type="checkbox"/>		<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWING</b> 6	<b>TOTAL CLAIMS</b> 29
Verified and Acknowledged Examiner's Signature: <i>Nathan H. Brown</i> Initials: AB		<b>INDEPENDENT CLAIMS</b> 3		
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<b>TITLE</b> Optical metrology of structures formed on semiconductor wafer using machine learning systems				
<b>FILING FEE RECEIVED</b> 912	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	